

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	Examiner: Wai Lun Leung
Christopher M. Look	)	
	)	Art Unit: 2613
Serial No.: 10/785,618	)	
	)	Confirmation No.: 2967
Filed: February 23, 2004	)	
	)	
For: Method and Apparatus to Provide	)	
<u>Optical Equipment Protection</u>	)	
Mail Stop Issue Fee		
P.O. Box 1450		
Alexandria, VA 22313-1450		

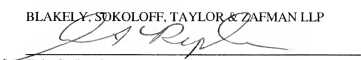
**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**

Applicants are assuming that the Examiner's statement of reasons for allowance is to be taken in light of the structure and interaction recited in the claims. Applicants note that the Examiner's various comments should not be used to read non-existent limitations into the claims.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: October 29, 2010

  
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**CERTIFICATE OF TRANSMISSION**

I hereby certify that this document is being submitted via EFS-WEB  
on: October 29, 2010  
Assistant: /Carla Anyisia Nascimento/